

PATENT APPLICATION

IN THE UNITED STATES PATENT AND TRADEMARK OFFICE

In re application of  
Koichi TERASHIMA, et al.  
Appln. No.: 10/544,783  
Confirmation No.: 5339  
Filed: August 8, 2005  
For: METHOD FOR FORMING NICKEL SILICIDE FILM, METHOD FOR MANUFACTURING SEMICONDUCTOR DEVICE, AND METHOD FOR ETCHING NICKEL SILICIDE

Docket No: Q89627  
Group Art Unit: 1722  
Examiner: Pape A. SENE

**RESPONSE TO ELECTION OF SPECIES REQUIREMENT**

Mail Stop Amendment  
Commissioner for Patents  
P.O. Box 1450  
Alexandria, VA 22313-1450

Sir:

This responds to the Election of Species Requirement, dated February 12, 2008. In response to the Examiner's Election of Species Requirement, Applicants elect Species I, Figures 3A and 3B in which claims 1-12, 58 and 59 read. Also, claims 2, 3, 8, 9 and 12 are generic. This Species election is without traverse.

Applicants reserve the right to file Divisional Applications directed to non-elected claims.

The USPTO is directed and authorized to charge all required fees, except for the Issue Fee and the Publication Fee, to Deposit Account No. 19-4880. Please also credit any overpayments to said Deposit Account.

Respectfully submitted,

  
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Date: April 11, 2008